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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10045542	FILING DATE 10/25/2001	CLASS 427	SUBCLASS 377	GAU 1762	EXAMINER B...
** APPLICANTS: Das Mirnal; Lipkin Lori;					
** CONTINUING DATA VERIFIED: <i>is a CIP of 09/968,391 10/1/2001 which</i>					
THIS APPLN CLAIMS BENEFIT OF 60/294,307 05/30/2001					
AND IS A CIP OF 09/934,283 04/12/2001					
WHICH CLAIMS BENEFIT OF 60/237,822 10/03/2000					
AND CLAIMS BENEFIT OF 60/237,426 10/03/2000					
** FOREIGN APPLICATIONS VERIFIED: <i>none 7</i>					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>			RESCIND <input type="checkbox"/>		
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no			ATTORNEY DOCKET NO		
35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no			5308-1571P2		
Verified and Acknowledged Examiners's Initials <i>[Signature]</i>					
TITLE: Method of fabricating an oxide layer on a silicon carbide layer utilizing an anneal in a hydrogen environment					
U.S. DEPT. OF COMM./PAT. & TM-PTO-436 (Rev. 12-94)					

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NOTICE OF ALLOWANCE MAILED <i>6-27-03</i>		CLAIMS ALLOWED Total Claims <i>20</i> Print Claim for O.G. <i>1</i>	
ISSUE FEE Amount Due <i>\$1600</i> Date Paid		DRAWING Sheets Drwg. <i>6</i> Figs. Drwg. <i>8</i> Print Fig. <i>1.4</i>	
PRIMARY EXAMINER <i>[Signature]</i> Primary Examiner		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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